

35.G2387



PATENT APPLICATION

37-2
#3
5/18/00
P.M.

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:) Examiner: Unassigned
HIDEHIKO FUJIMURA, ET AL.) Group Art Unit: Unassigned
Application No.: 09/309,766)
Filed: May 11, 1999)
For: METHOD FOR MANUFACTURING) November 2, 1999
AIRTIGHT VESSEL AND)
IMAGE-FORMING APPARATUS)
USING AIRTIGHT VESSEL)

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The Assistant Commissioner for Patents
Washington, D.C. 20231

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INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under
37 C.F.R. § 1.56 and in accordance with the practice under
37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is
directed to the documents listed on the enclosed Form
PTO-1449. Copies of the listed documents are also enclosed.

The concise explanations of relevance for the non-
English documents are provided in the Description of Related
Art section of the specification.

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CONCLUSION

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It is respectfully requested that the above
information be considered by the Examiner and that an

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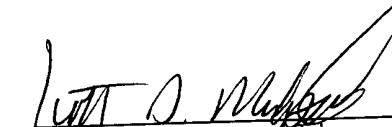
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initialized copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Ruth J. Mulligan
Attorney for Applicants

Registration No. 32,533

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New York, New York 10112-3801
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SDM\rnm

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICELIST OF REFERENCES CITED BY APPLICANT(S)
(Use several sheets if necessary)

Submitted to the PTO: November 2, 1999

APPLICANTS
HIDEHIKO FUJIMURA, ET AL.

NOV 02 1999

FILING DATE
May 11, 1999GROUP
Unassigned

U.S. PATENT DOCUMENTS

PATENT & TRADEMARK OFFICE

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	5,925,979	07/1999	Azuma, et al.	313	495	RECEIVED
						RECEIVED
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						RECEIVED

FOREIGN PATENT DOCUMENTS

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	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
	7-302545	11/1995	Japan			Abstract
	7-296748	11/1995	Japan			Abstract
	7-296731	11/1995	Japan			Abstract
						RECEIVED
						RECEIVED
						RECEIVED

OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)

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	W.P. Dyke, et al., "Field Emission", Advances in Electronics and Electron Physics, pp. 90-185 (1956).
	C.A. Spindt, et al., "Physical Properties of Thin-Film Field Emission Cathodes with Molybdenum Cones", Journal of Applied Physics, Vol. 47, No. 12, pp. 5248-5263 (December 1976).
	C.A. Mead, "Operation of Tunnel-Emission Devices", Journal of Applied Physics, Vol. 32, No. 4, pp. 646-652 (April 1961).
	M.I. Elinson, et al., "The Emission of Hot Electrons and the Field Emission of Electrons From Tin Oxide", Radio Engineering and Electronic Physics, No. 7, pp. 1290-1296 (July 1965).
	G. Dittmer, "Electrical Conduction and Electron Emission of Discontinuous Thin Films", Thin Solid Films, Vol. 9, pp. 317-328 (1972).
	H. Araki, et al., "Electroforming and Electron Emission of Carbon Thin Films", Journal of Vacuum Society of Japan, Vol. 26, No. 1, pp. 22-29 (January 1983).
	M. Hartwell, et al., "Strong Electron Emission From Patterned Tin-Indium Oxide Thin Films", International Electron Devices Meeting, pp. 519-521 (1975).

EXAMINER

DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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Sheet 1 of 1